

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	11672	(356/399-401,614-616,624,630-632,445-448,237.1-237.6,238.1,238.3).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 16:34
L2	5885	(382/141,144,145,147,148,152,286,289,291,292,298,299,149,151).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:08
L3	1157	(250/559.01,559.29,559.3).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:08
L4	2228	(702/94,95,150-153,38).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:10
L5	7491	(355/53,55,77).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:20
L6	8276	(430/5,22,30).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:20
L7	438	(269/329,63,4).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:20
L8	561	(348/88,92,82,95).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:20
L9	1145	(700/114,186,192-194,257).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:20
L10	948	(414/935,936).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:21
L11	428	(345/649,672).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/24 17:21
L12	1174	(1 2 3 4 5 6 7 8 9 10 11) and ("2006121"\$1.pd. "2007"\$4.pd.)	US-PGPUB; USPAT; USOCR	OR	ON	2007/04/24 17:59
L13	22	12 and ((prealign\$4 pre\$1align\$4) same (wafer semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2007/04/24 17:25
L14	14	12 and (((edge notch) near detect\$3) same (wafer semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2007/04/24 17:38
L15	42	12 and (imag\$3 near (rotat\$4 rotation\$4))	US-PGPUB; USPAT; USOCR	OR	ON	2007/04/24 17:58

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L16	587	((prealign\$4 pre\$1align\$4) same (wafer semiconduct\$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 17:59
L17	1	16 and ("2006121"\$1.pd. "2007"\$4.pd.)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 18:07
L18	451	(((edge notch) near detect\$3) same (wafer semiconduct\$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 18:00
L19	1	18 and ("2006121"\$1.pd. "2007"\$4.pd.)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 18:08
L20	65	(imag\$3 near (rotat\$4 rotation\$4)) and ("2006121"\$1.pd. "2007"\$4.pd.)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 18:11
L21	3	20 and (wafer semiconduct\$3)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/24 18:13
L22	911	(((edge notch peripher\$2) same wafer) same (rotat\$4 rotation\$4)).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:27
L23	621	22 and (align\$4 position\$3).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:45
L24	35	23 and ((locat\$3 detect\$3) near (edge notch)).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:51
L25	350	(((lateral\$ translat\$5) same (rotat\$4 rotation\$4)) same (wafer semiconduct\$3)).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:59
L26	0	25 and (rotat\$3 near imag\$3).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:59
L27	14	25 and (rotat\$3 same imag\$3).clm.	US-PGPUB; USPAT	OR	ON	2007/04/24 18:59